

# UNITED STATES DEPARTMENT OF COMMERCE **Patent and Trademark Office**

COMMISSIONER OF PATENTS AND TRADEMARKS Washington, D.C. 20231

APPLICATION		DATE	FIRST NAMED INVENTOR	т Т	ATTORNEY DOCKET NO.	
OBLOI FOUR	OB/578,980 12/27/95 KAMAKUKA  MM21/0724  OBLON SPIVAK MCCLELLAND MAIER & NEUSTADT  FOURTH FLOOR				WILLE, P	
	JEFFERSON GTON VA 2		IIGHWAY	ART UNIT	PAPER NUMBER 07/24/98	
				DATE MAILED	<b>-</b>	

Please find below and/or attached an Office communication concerning this application or proceeding.

**Commissioner of Patents and Trademarks** 

Application No. 08/578,980

Applicant(s)

Kamakura

Office Action Summary

Examiner Douglas Wille

Group Art Unit 2814



Responsive to communication(s) filed on Jun 9, 1998	<u> </u>
★ This action is FINAL.	
☐ Since this application is in condition for allowance except for in accordance with the practice under <i>Ex parte Quayle</i> , 193	
A shortened statutory period for response to this action is set is longer, from the mailing date of this communication. Failure application to become abandoned. (35 U.S.C. § 133). Extens 37 CFR 1.136(a).	to respond within the period for response will cause the
Disposition of Claims	
	is/are pending in the application.
Of the above, claim(s)	is/are withdrawn from consideration.
☐ Claim(s)	is/are allowed.
☐ Claim(s)	
☐ Claims	
Application Papers	
☐ See the attached Notice of Draftsperson's Patent Drawin	
☐ The drawing(s) filed on is/are object	cted to by the Examiner.
☐ The proposed drawing correction, filed on	is _approved _disapproved.
$\square$ The specification is objected to by the Examiner.	
$\hfill\Box$ The oath or declaration is objected to by the Examiner.	
Priority under 35 U.S.C. § 119	
Acknowledgement is made of a claim for foreign priority	under 35 U.S.C. § 119(a)-(d).
☐ All ☐ Some* ☐ None of the CERTIFIED copies	of the priority documents have been
received.	
☐ received in Application No. (Series Code/Serial Nu	
received in this national stage application from the	e International Bureau (PCT Rule 17.2(a)).
*Certified copies not received:	·
☐ Acknowledgement is made of a claim for domestic prior	ity under 35 U.S.C. § 119(e).
Attachment(s)	
□ Notice of References Cited, PTO-892	
☐ Information Disclosure Statement(s), PTO-1449, Paper N	lo(s)
☐ Interview Summary, PTO-413	148
<ul> <li>□ Notice of Draftsperson's Patent Drawing Review, PTO-9</li> <li>□ Notice of Informal Patent Application, PTO-152</li> </ul>	<del></del>
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SEE OFFICE ACTION ON	THE FOLLOWING PAGES

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#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 102

- 1. The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.
- 2. Claims 1, 3 and 5 are rejected under 35 U.S.C. 102(b) as being anticipated by Scifres et al.
- 3. With respect to claim 1, Scifres et al. describe a double hetero-structure LED (see Figure 2 and column 4, lines 13 30) with an AlGaAs clad layer 31, an undoped InGaAs active layer 29 and a second AlGaAs clad layer 25 which uses a strain layer 27 to prevent defect migration to the active region (column 1, line 44). Scifres et al. do not specifically state the thickness of the cladding layers but all Figures show the layers as being equal.
- 4. With respect to claim 3, the hetero-junction employs an undoped layer between two cladding layers.
- 5. With respect to claim 5, Scifres et al. discuss the use of a buffer layer (column 3, line 33).

### Claim Rejections - 35 USC § 103

- 6. Claims 2 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Scifres et al. in view of Inoue et al.
- 7. With respect to claim 2, Scifres et al. show the use of a strain layer to prevent defect migration and discuss the use of a buffer layer (column 3, line 33), which is known to also limit

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defect migration and also discuss adding other strain layers (column 4, line 64). Inoue et al. discuss (see abstract) the use of multiple defect regions to limit defect migration and it would have been obvious to include a second strain layer as taught by Inoue et al. to supplement the buffer region.

- 8. With respect to claim 8, Scifres et al. discuss the basic device structure and refer to the strain layer thickness as being approximately 10 nm (column 4, line 47). Scifres et al. also discusses the lattice mismatch as being less than or equal to 4% (column 4, line 49). Inoue et al. discusses the defect density as being in the range of 10<sup>6</sup>/cm<sup>2</sup> which corresponds to a value greater than 10<sup>4</sup>/cm<sup>2</sup>. It would have been obvious to provide the Scifres et al. device with the defect density taught by Inoue et al. to improve the defect protection.
- 9. Claim 4 is rejected under 35 U.S.C. 103(a) as being unpatentable over Scifres et al. in view of Sugawara et al.
- 10. Scifres et al. describe a double hetero-structure LED. Sugawara et al. discuss a LED structure which specifically calls out a current spreading layer 15 (cover Figure) and detail the use of a buffer layer 32 (Figure 6). It would have been obvious to include the current spreading layer and the buffer layer to provide a more uniform output with improved reliability.
- 11. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Scifres et al. in view of Sugawara et al.
- 12. Scifres et al describe a double hetero-junction LED with clad layers enclosing an undoped region and having a strain layer to prevent defect migration. Sugawara et al. provide details of a

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buffer layer 32 (Figure 6), a current spreading layer 15 (cover Figure) and a reflective layer 33 (Figure 6). It would have been obvious to one skilled in the art at the time of the invention to include the current spreading layer, the buffer layer, and the reflective layers to improve device reliability and performance.

- 13. Claim 9 is rejected under 35 U.S.C. 103(a) as being unpatentable over Scifres et al. in view of Sugawara et al. and further in view of Inoue et al.
- 14. Scifres et al. describe a double hetero-junction LED with clad layers enclosing an undoped region and having a strain layer to prevent defect migration. Sugawara et al. provide details of a buffer layer 32 (Figure 6), a current spreading layer 15 (cover Figure) and a reflective layer 33 (Figure 6). Scifres et al. discusses the strain layer thickness as being approximately 10 nm (column 4, line 47). Scifres et al. also discusses the lattice mismatch as being less than or equal to 4% (column 4, line 49). Inoue et al. discusses the defect density as being in the range of 10<sup>6</sup>/cm<sup>2</sup> which corresponds to a value greater than 10<sup>4</sup>/cm<sup>2</sup>.
- 15. Claims 5, 7 and 10 are rejected under 35 U.S.C. 103(a) as being unpatentable over Scifres et al. in view of Sugawara et al. and further in view of Inoue et al.
- 16. With respect to claim 7, Scifres et al. describe a double hetero-junction LED with clad layers enclosing an undoped region and having a strain layer to prevent defect migration.

  Sugawara et al. provide details of a buffer region, a current spreading region and a reflective layer. Inoue et al. describe the use of multiple defect controlling layers. It would have been obvious to modify the Scifres et al. device to include the current spreading layer, the details of the

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buffer layer, the reflective layers and a second layer as taught by Sugawara et al. and Inoue et al. to prevent defect migration and enhance the device output.

- 17. With respect to claim 5, Sugawara et al. describe the buffer layer as helping prevent defect migration (column 9, line 53).
- 18. With respect to claim 10, Scifres et al. discuss the strain layer thickness as being approximately 10 nm (column 4, line 47). Scifres et al. also discuss the lattice mismatch as being less than or equal to 4% (column 4, line 49). Inoue et al. discuss the defect density as being in the range of 10<sup>6</sup>/cm<sup>2</sup> which corresponds to a value greater than 10<sup>4</sup>/cm<sup>2</sup>.

### Response to Arguments

- 19. Applicant's arguments filed 9 June 1998 have been fully considered but they are not persuasive.
- 20. Applicant argues that Scifres et al. do not show the claimed structure since the strain layer is in the clad layer. Note however, that the strain layer has a different composition from the clad layer and therefore qualifies as a separate layer. Applicant also states that Scifres et al. cannot be read on the claim since it doesn't agree with the specification. Nevertheless, Scifres et al. do show the claimed structure regardless of what is in the specification.
- 21. Applicant argues that Scifres et al. discuss the clad layers as having a typical thickness of 1 micron and quotes the Scifres et al. statement that the strain layer must be at least 0.5 microns away from the active layer to mean that the clad layer would thus be reduced to a non equal

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thickness. Note however that Scifres et al. only quote a minimum thickness to prevent interference with the bandgap of the active layer and in no way imply that the clad layers have unequal thickness. In fact, Figure 2 shows the clad layers 25 and 31 as having the same thickness.

- 22. Applicant argues that Inoue et al. cannot be combined with Scifres et al. but the combined teaching is for multiple defect regions and since they are both part of the prior art and their teachings show benefits it is entirely proper to combine their teachings.
- 23. Applicant argues that Inoue et al. cannot be used to show a defect density of 10<sup>6</sup> /cm<sup>2</sup> since it is not shown in the abstract. Note however that is shown elsewhere in Inoue et al. (column 4, line 34).
- 24. Applicant argues that Sugawara et al. do not cure deficiencies of Scifres et al. Yet, Scifres et al. and Inoue et al. show the basic claimed structure and Sugawara et al. is relied upon to teach the use of a buffer layer on a substrate, a current spreading layer and a reflective layer which all have well documented benefits.

#### **Conclusions**

- 25. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).
- 26. A shortened statutory period for response to this final action is set to expire THREE MONTHS from the date of this action. In the event a first response is filed within TWO

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MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event will the statutory period for response expire later than SIX MONTHS from the date of this final action.

- 27. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Douglas A. Wille whose telephone number is (703) 308-4949.
- 28. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Group receptionist whose number is (703) 308-0956.

Olik Chaudhuri

Supervisory Patent Examiner

Olh Chaus

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July 21, 1998